Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR	OFF	2005/05/17 12:43
L2	92	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and ((mirror$2 or micromirror$3) same stop$5)	USPAT	OR	OFF	2005/05/17 12:44
L3	284	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1	USPAT	OR	OFF	2005/05/17 12:44
S1	4	(("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")).PN.	USPAT	OR	OFF	2005/01/27 11:04
S2	1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 10:48
S3	0	method.ti. and fabricating.ti. and mircromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S5	3	method.ab. and fabricating.ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
S6	0	method.ti. and fabricate.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S7	0	method.ti. and fabricating.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
S8	9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR	OFF	2005/01/31 10:56
S9	5	fabricating.ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
S10	1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 16:28
S11	30	("3766205" | "4402573" | "4853471" | "4902108" | "5032498" | "5140455" | "5151816" | "5239406" | "5457564" | "5679283" | "5724187" | "5770114" | "5818636" | "5859722" | "5910854" | "5998617" | "6002511" | "6020987" | "6141137" | "6154306" | "6183878" | "6187845" | "6188505" | "6193912" | "6241916" | "6262832" | "6277307" | "6301038" | "6445486").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/01/31 18:45

S12	1218	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1	USPAT	OR	OFF	2005/05/15 19:24
S13	262	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (two with state$1)	USPAT	OR	OFF	2005/05/16 18:46
S14	124	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (two with state$1) and angle$1 and degree	USPAT	OR	OFF	2005/05/16 13:11
S15	91	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (post with ((polpolycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu))	USPAT	OR	OFF	2005/05/15 22:18
S16	35	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (post with ((polpolycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu)) and (post same (material or made))	USPAT	OR	OFF	2005/05/16 11:24
S17	0	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (post with (polpolycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S18	0	post$2 and (mirror$1 or micromirror$1) and (post with (polpolycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S19	0	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (post with (polpolycrystalline near silicon)) and dopped	USPAT	OR	OFF	2005/05/16 11:37
S20	0	post$2 and (mirror$1 or micromirror$1) and (post with (polpolycrystalline near silicon)) and dopped	USPAT	OR	OFF	2005/05/16 11:37
S21	0	post$2 and (mirror$1 or micromirror$1) and (post with (polpolycrystalline near silicon)) and dopped	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/05/16 11:37
S22	556	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and (state$1) and angle$1 and degree	USPAT	OR	OFF	2005/05/16 13:11

S23	1218	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and ((mirror$2 or micromirror$3) stop$5)	USPAT	OR	OFF	2005/05/16 18:47
S24	241	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and ((mirror$2 or micromirror$3) same stop$5)	USPAT	OR	OFF	2005/05/17 12:44
S25	115	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and (mirror$2 or micromirror$3) and (semiconductor$2 with (micromirror$ or mirror$1))	USPAT	OR	OFF	2005/05/16 21:59
S26	1	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and (mirror$2 or micromirror$3) and (semiconductor$2 with (micromirror$ or mirror$1)) and (semiconductor with dioxide)	USPAT	OR	OFF	2005/05/16 22:32
S27	34	"359"/$.ccls. and post$2 and (mirror$1 or micromirror$1) and state$1 and (mirror$2 or micromirror$3) and (semiconductor$2 with (micromirror$ or mirror$1)) and (silicon with dioxide)	USPAT	OR	OFF	2005/05/17 12:10